IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Osamu Goto, et al.

Application No. 10/606,176

Filed: June 25, 2003

For: Semiconductor Light Emitting

DEVICE, ITS MANUFACTURING METHOD,

SEMICONDUCTOR DEVICE AND ITS

MANUFACTURING METHOD

Group Art Unit: 2811

Examiner: Ori Nadav

I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: MAIL STOP AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on October 21,

Roxanne M. Swartz

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO JUNE 23, 2005 OFFICE ACTION

Dear Sir:

This Amendment is submitted in response to the Office Action mailed June 23, 2005. Applicants respectfully request amendment of the patent application, and reconsideration and allowance of the pending claims.